

Picosecond X-Ray Pulse Compression Optics Following RF Bunch Deflection

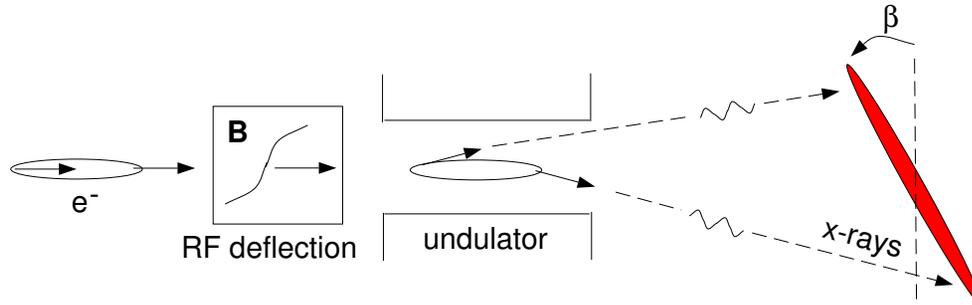
S. D. Shastri, R. J. Dejus, L. Assoufid

**APS
Argonne National Laboratory**

Advanced Photon Source



RF Deflection Followed by . . .



RF voltage: 4 MV
RF freq: $8 \times 352 \text{ MHz} = 2.8 \text{ GHz}$

Gives deflection gradient $\pm 380 \mu\text{rad} / \sigma_t$
where $\sigma_t = 40 \text{ ps}$ is r.m.s. bunch length

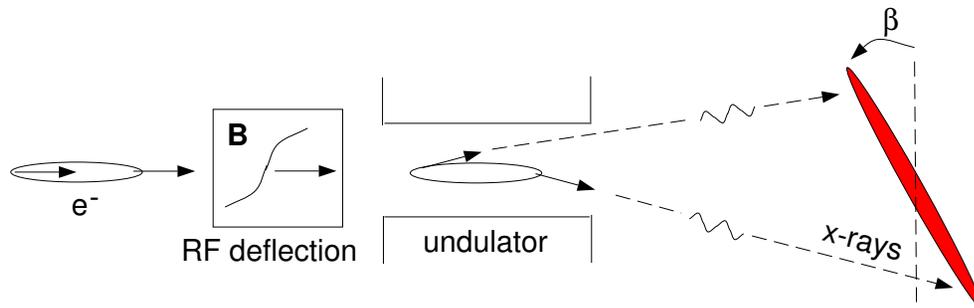
For x-rays at 30 m, $\beta = \pm 46^\circ$,
 $1 \sigma_t$ vertically dispersed by 11.6 mm

Zholents, et al., NIM A425, 385-389 (1999)

. . . Pulse Compression Optics

- x-ray tilt-rotation by asymmetric crystals
- undulator radiation following RF bunch deflection
- ps compression concept using Bragg geometry and mirrors
- flux and tunability: optimization over 5 - 40 keV
- geometrical effects
- mirror issues
- Laue geometry and bent crystals

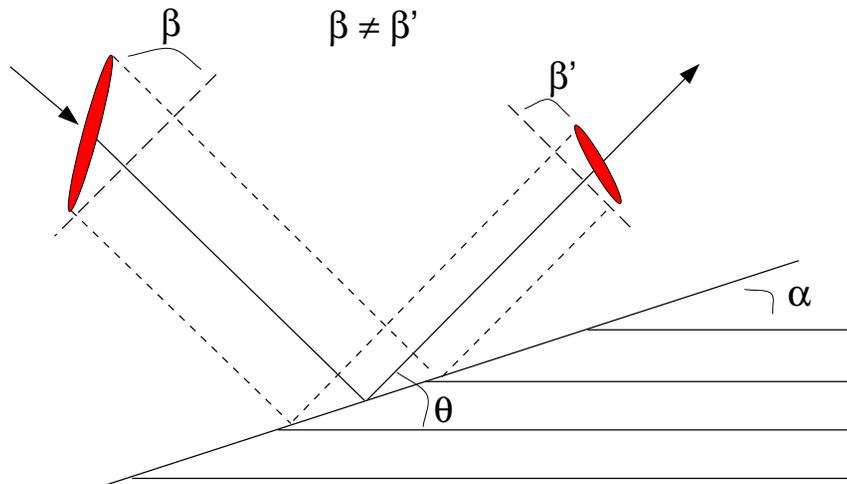
RF Deflection Followed by Tilt - Rotation by Asymmetric Crystals



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Bragg geometry - $\theta < \alpha < \theta$

Laue geometry $\theta < \alpha < 180^\circ - \theta$

Rotation

$$\tan \beta' = \frac{\tan \beta \sin (\theta + \alpha) - 2 \sin \theta \sin \alpha}{\sin (\theta - \alpha)}$$

Beam size magnification

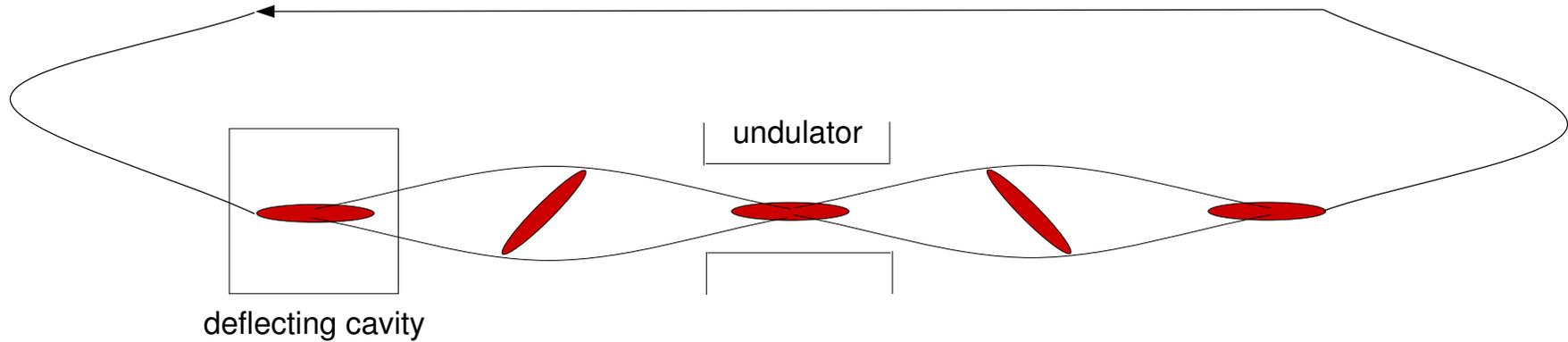
$$1 / |b|$$

$$b = \frac{\sin (\theta + \alpha)}{\sin (\alpha - \theta)}$$

Angular divergence change

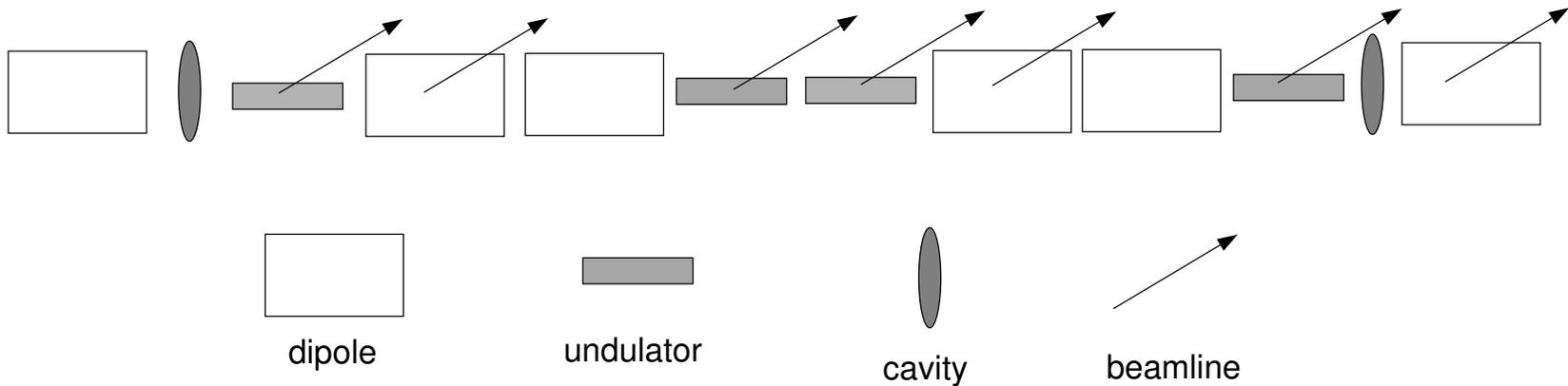
$$\Delta\theta \longrightarrow -b \Delta\theta$$

Betatron Oscillations Enable ...

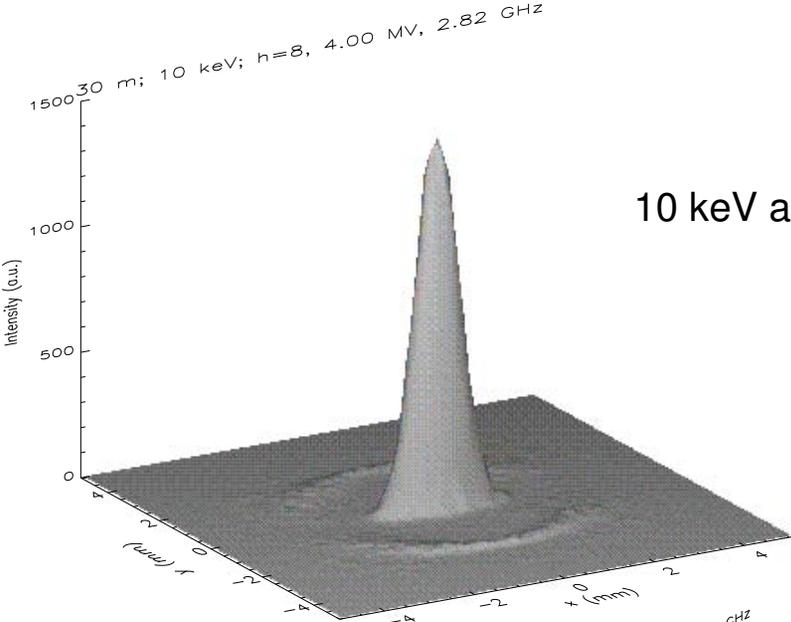


... Multiple Picosecond Beamlines Inside 2 Deflecting Cavities

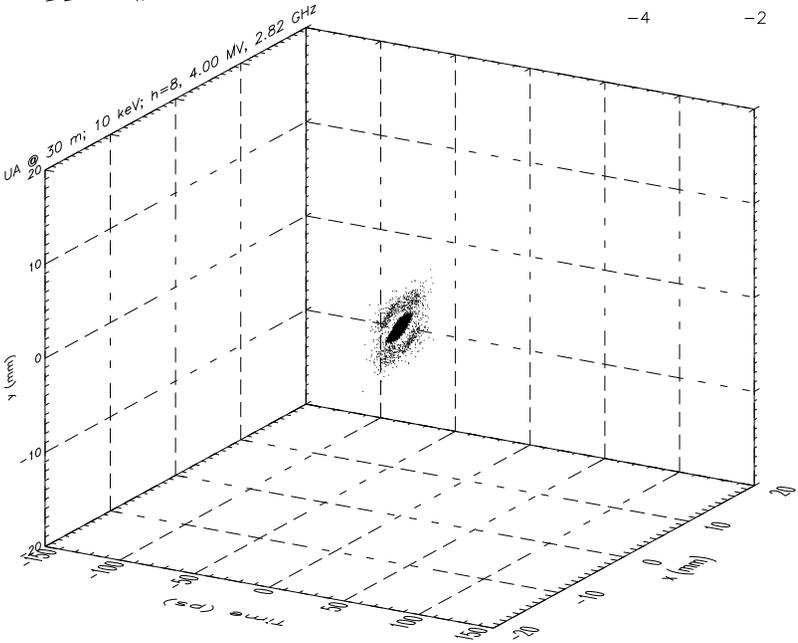
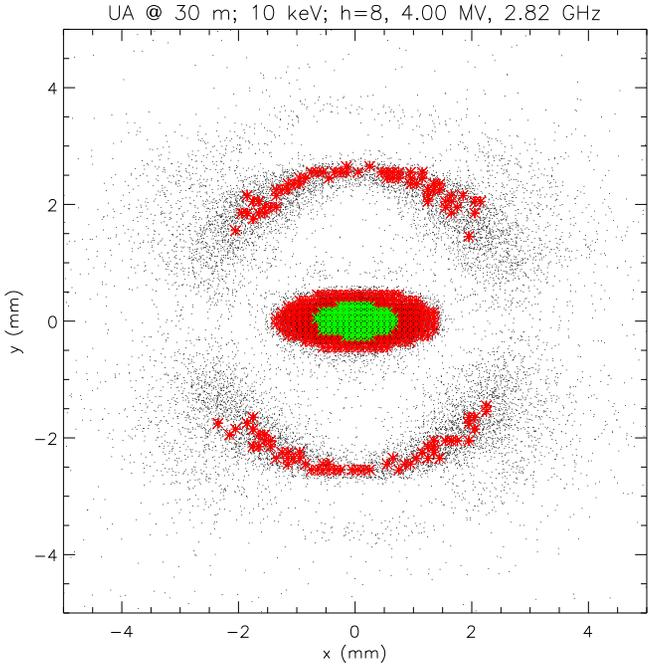
Example: 3 straight sections, 4 IDs, 2 BMs



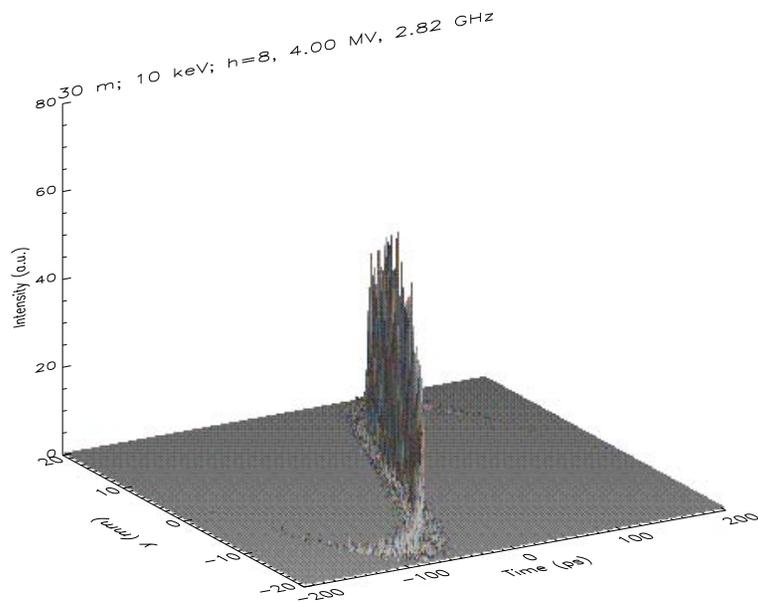
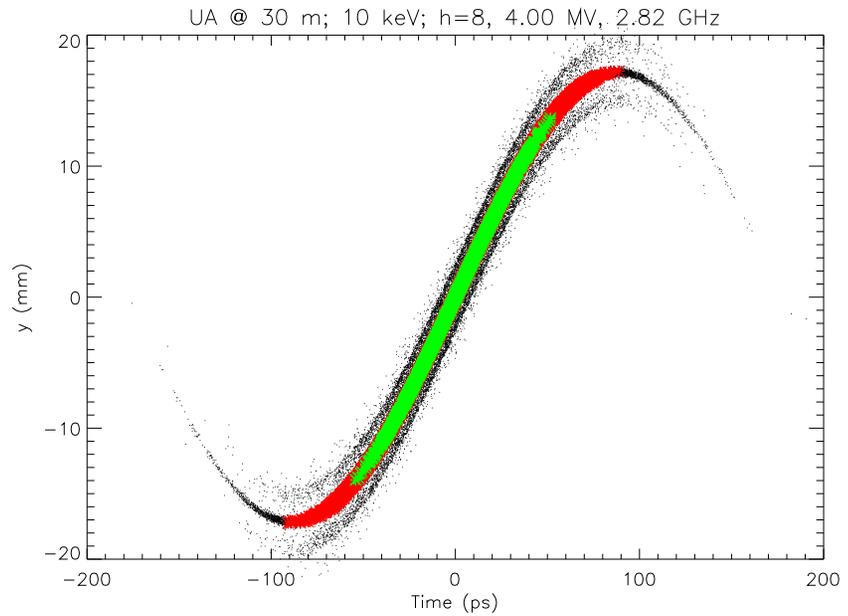
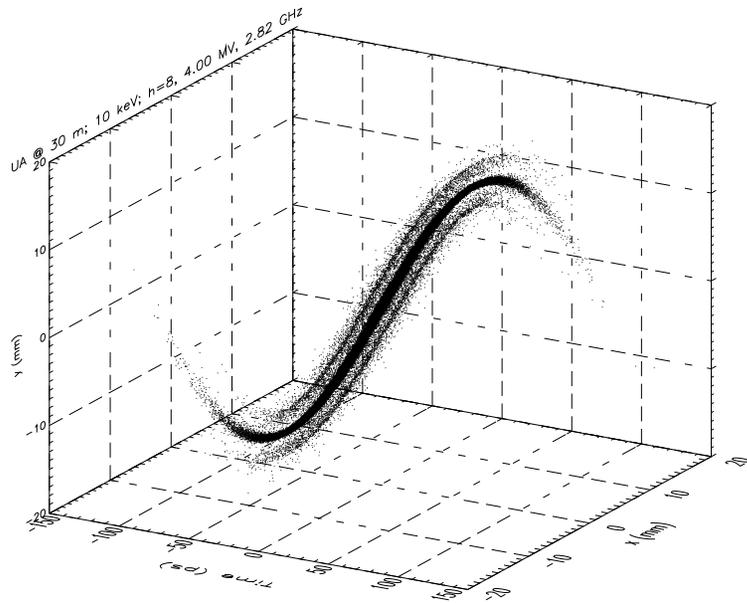
UA Central Cone - No RF Deflection (or Single Slice with Deflection)



10 keV at 30 m



Undulator Radiation with RF Deflection - 10 keV at 30 m

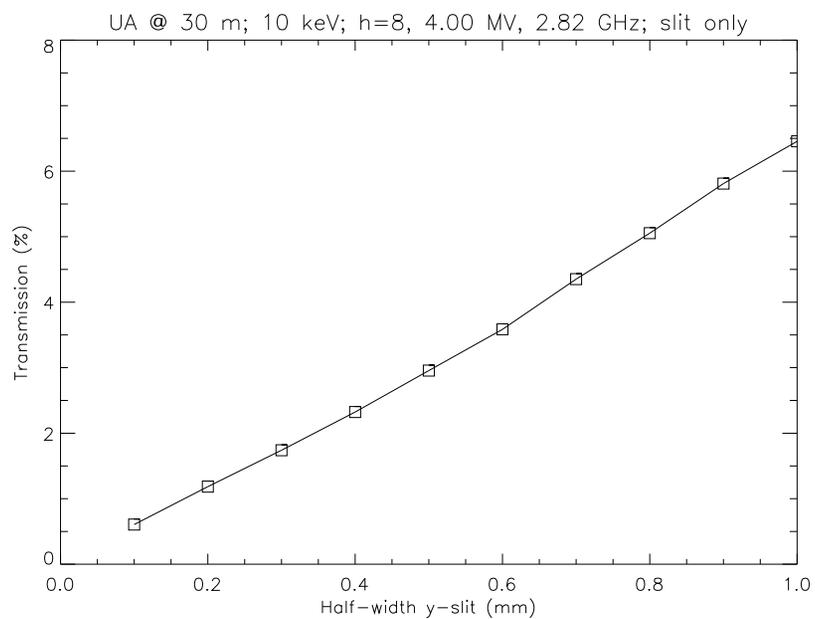
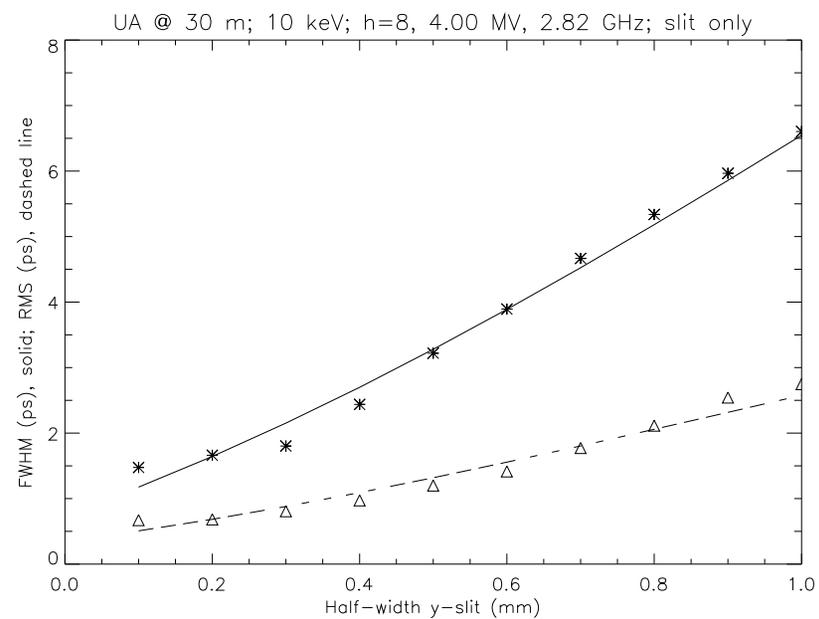
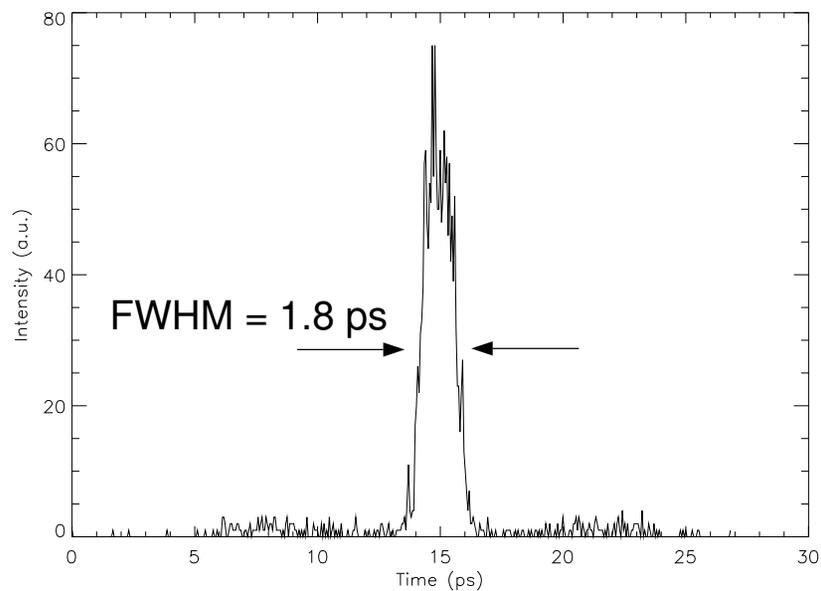


$$\sigma_x = 245 \mu\text{m} \quad \sigma_{x'} = 12.3 \mu\text{rad}$$

$$\sigma_y = 12.3 \mu\text{m} \quad \sigma_{y'} = 2.0 \mu\text{rad}$$

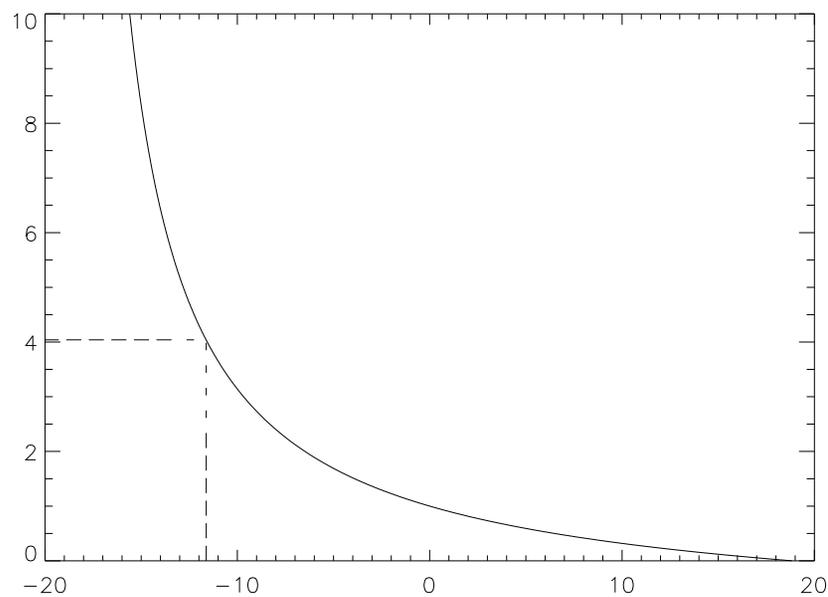
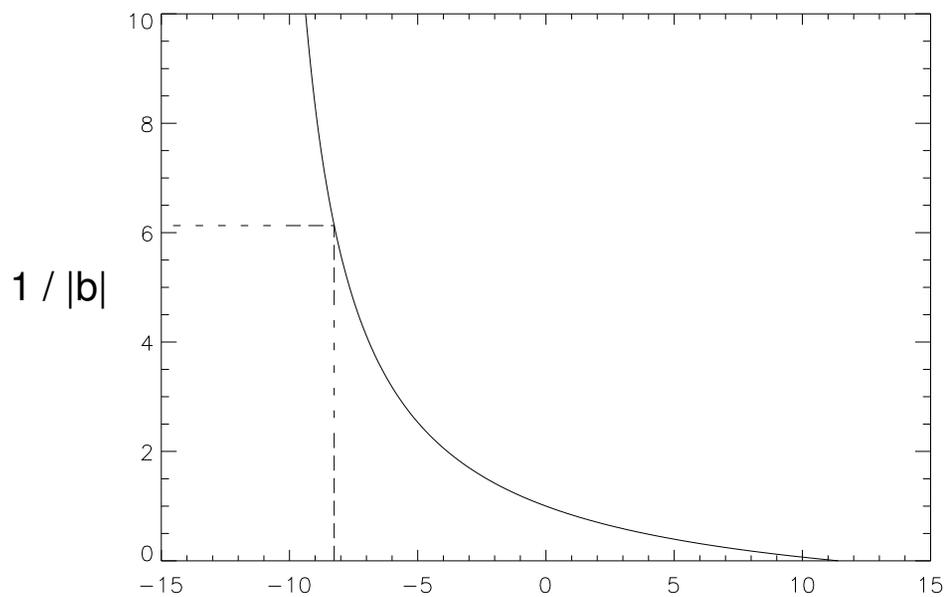
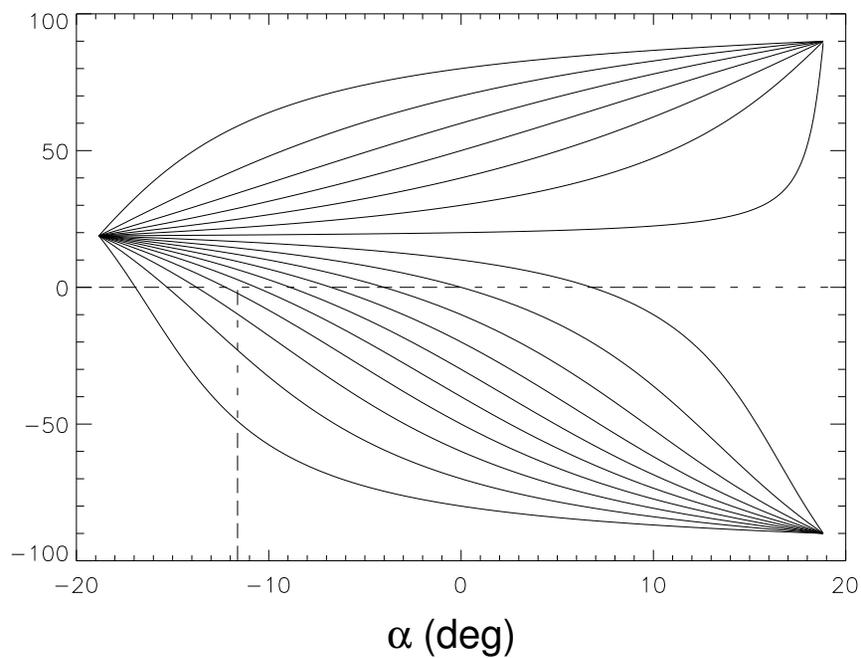
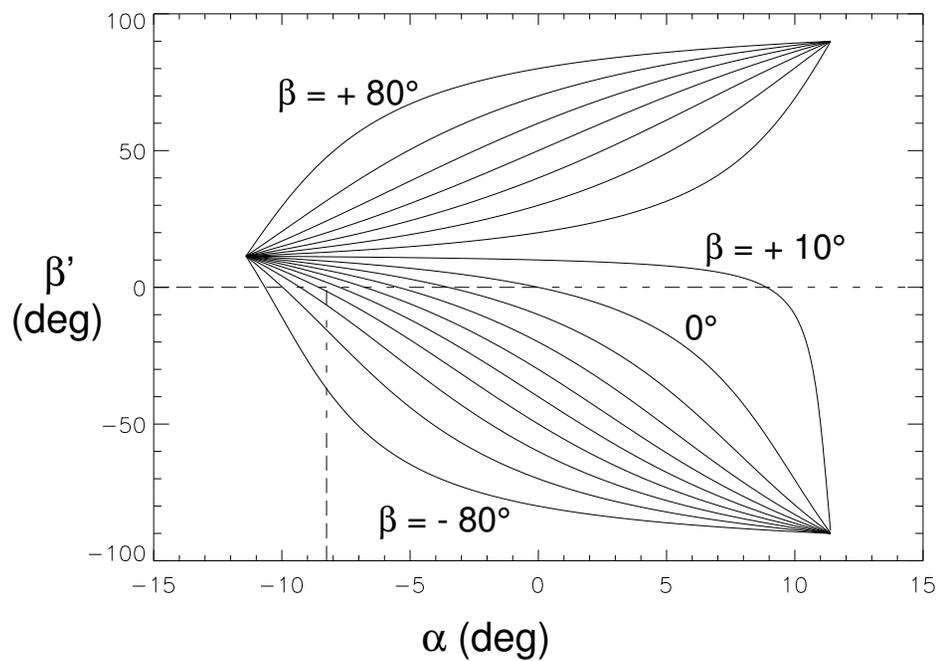
$$\sigma_E / E = 0.001$$

Slits Only - No Optics Compression



Tilt - Rotation, 10 keV, Bragg Geometry

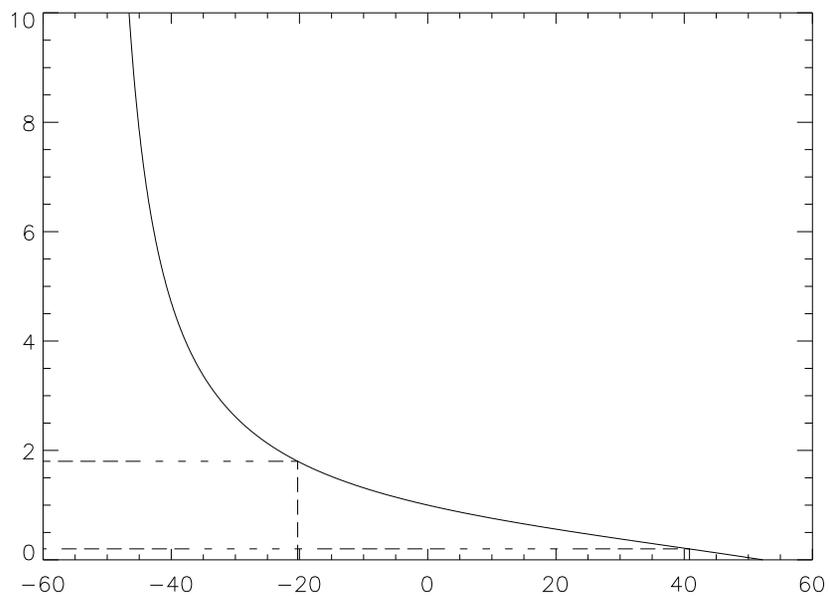
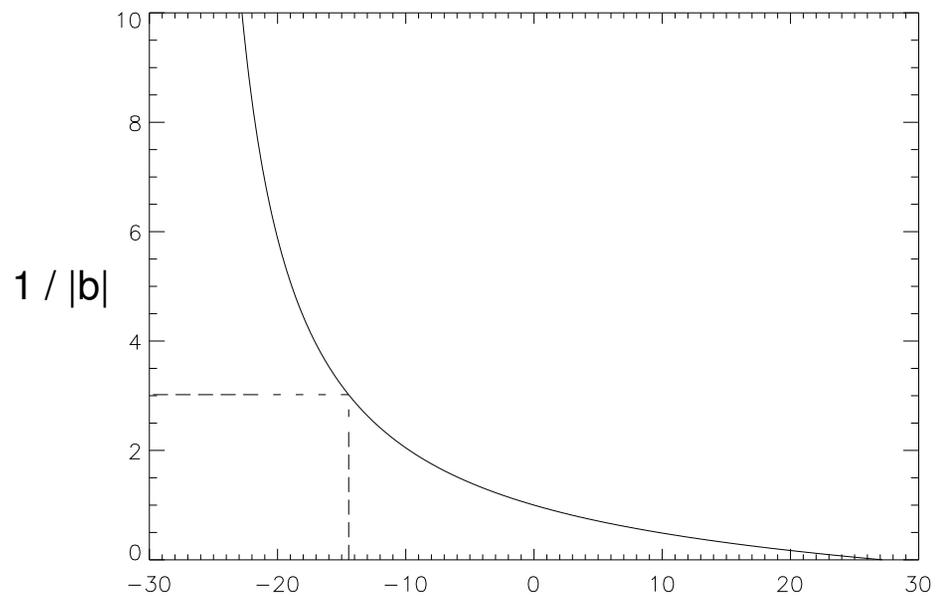
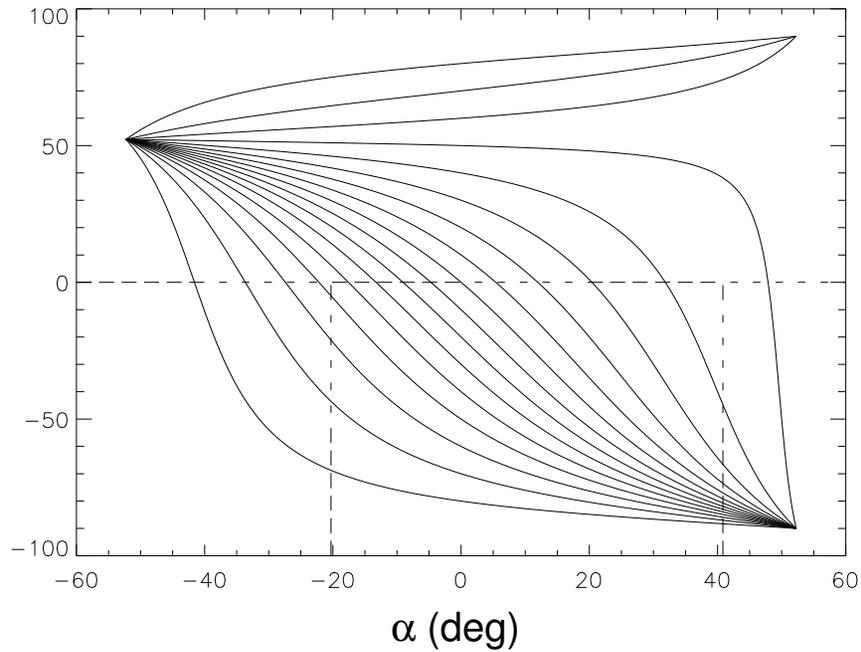
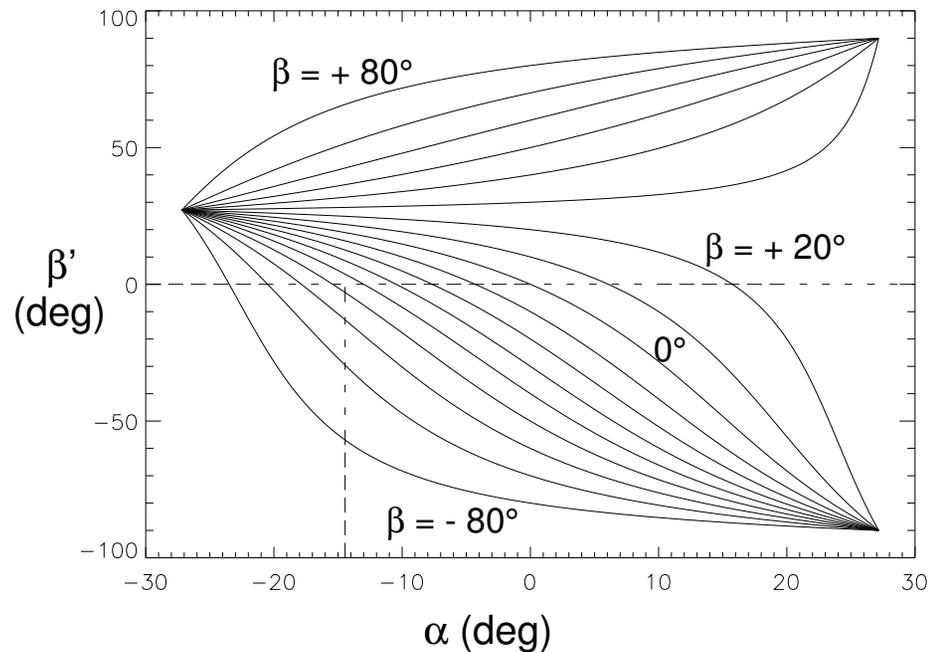
Si(111) Si(220)



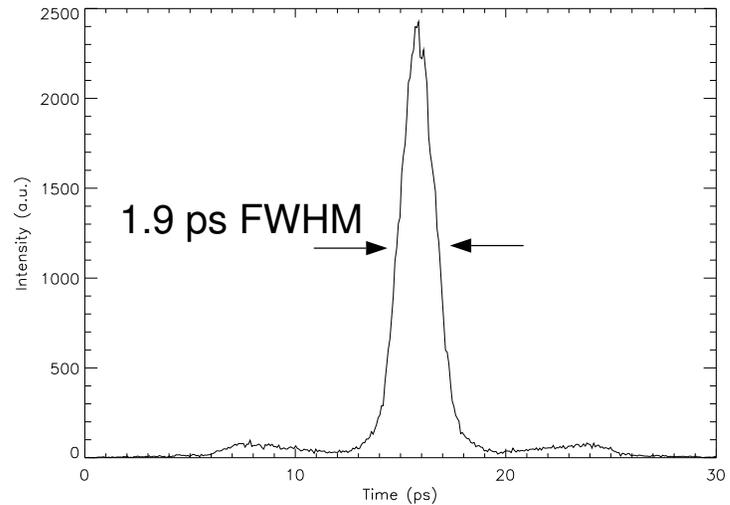
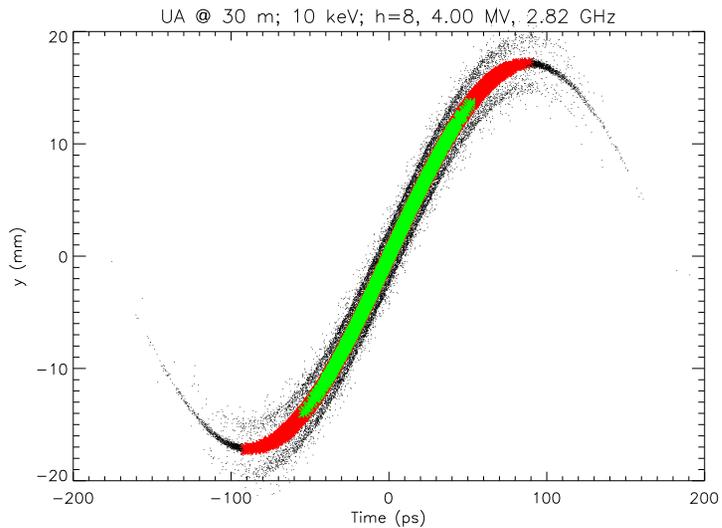
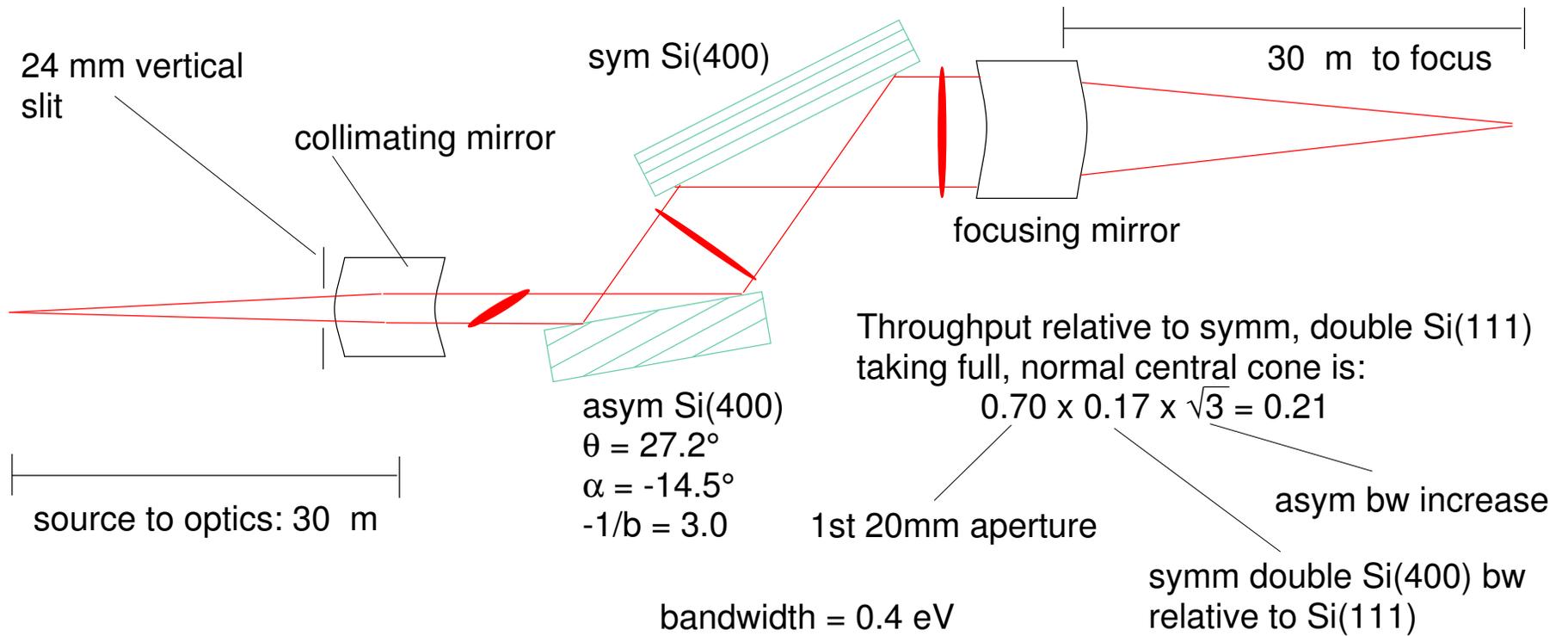
Tilt - Rotation, 10 keV, Bragg Geometry

Si(400)

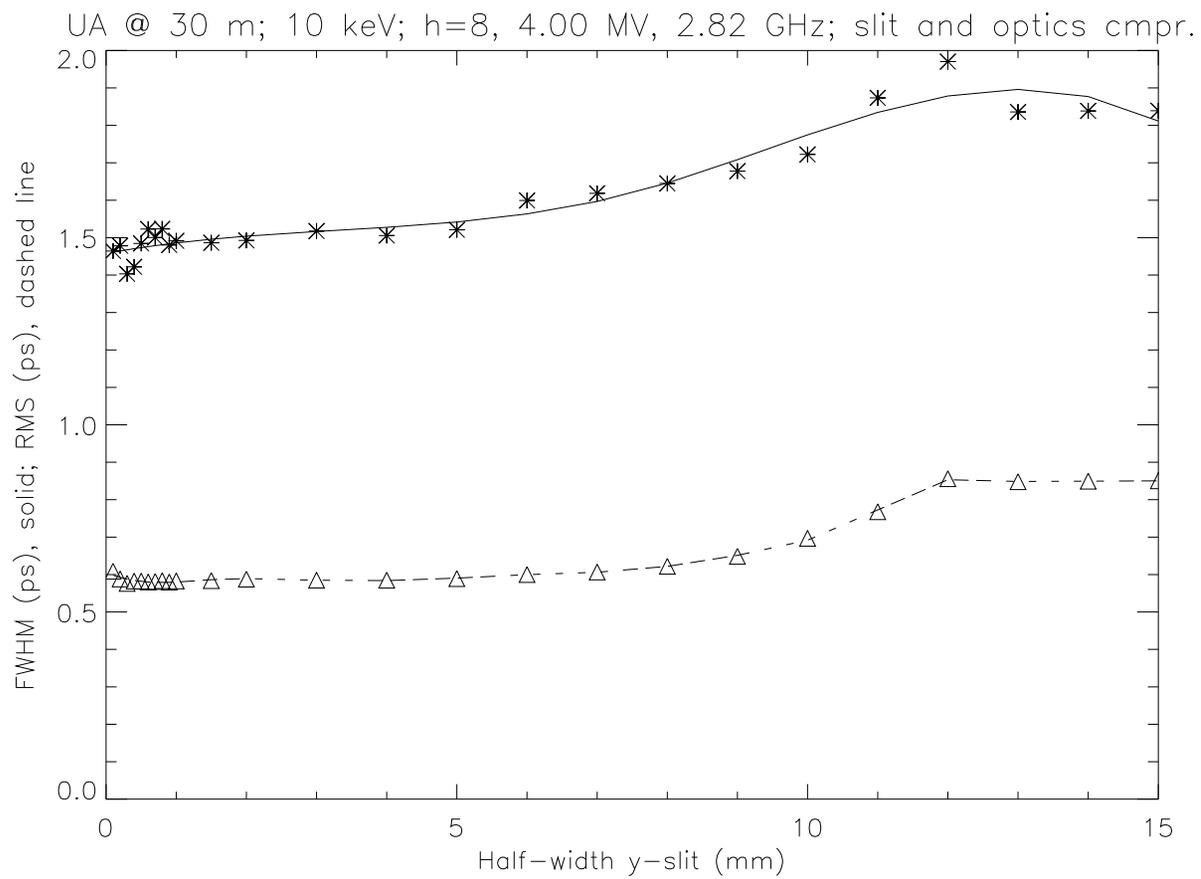
Si(444)



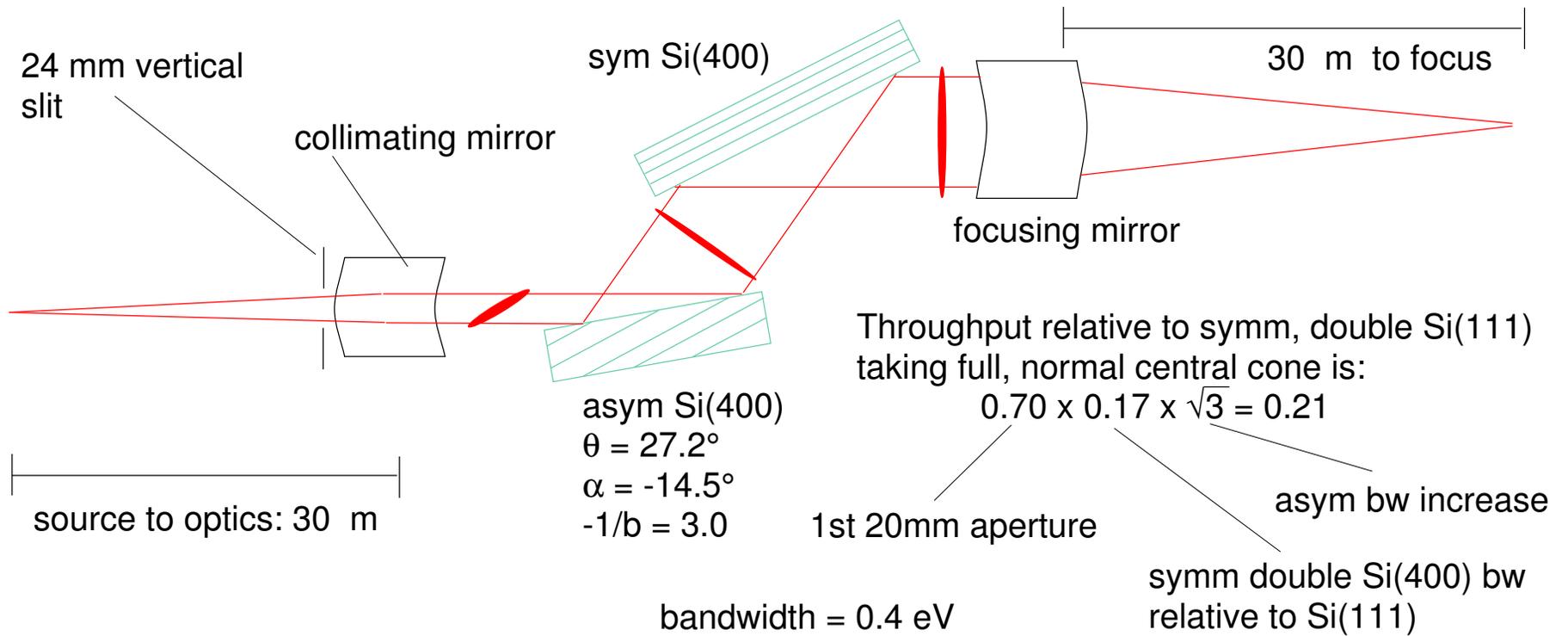
Pulse Compression Concept: 10 keV and Si(400) Example



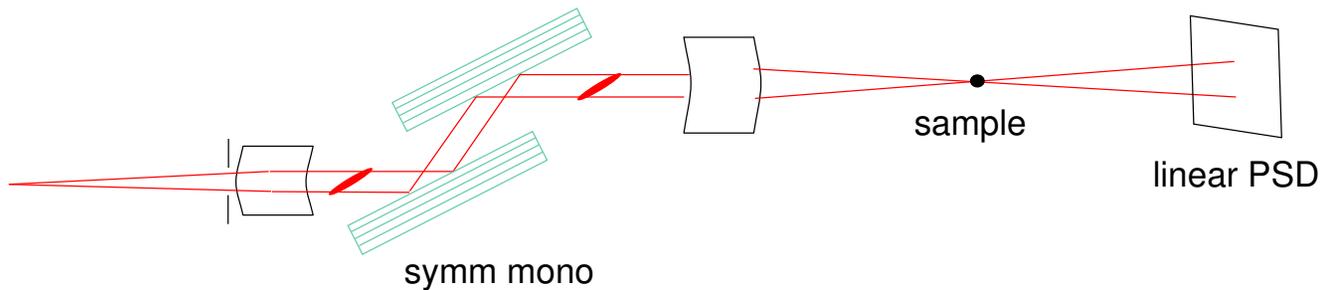
Optics Compression Pulse Widths



Pulse Compression Concept: 10 keV and Si(400) Example



Picosecond Time-Resolution Without Picosecond Pulses



Throughput Optimization of Pulse Compression Monochromators

Optimization assuming:

- 24 mm first aperture
- 200 mm long crystals
- 100 mm aperture after crystals (before focusing mirror)
- 100% mirror reflectivities

Example - Analysis of Si(111)
at 10 keV

$$\theta = 11.403^\circ$$

$$\alpha_1 = -8.4^\circ \quad \alpha_2 = .3^\circ$$

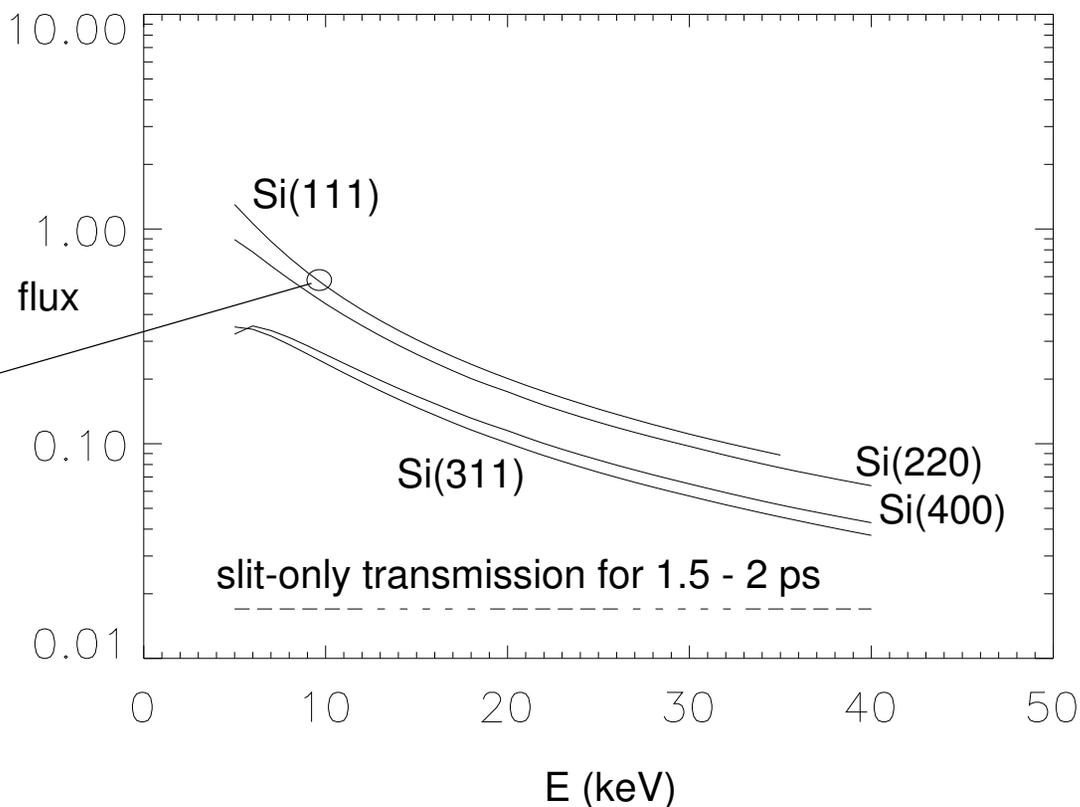
$$-1/b_1 = 6.5 \quad -1/b_2 = 0.95$$

crystal system's vertical aperture = 24 mm x 0.44 x 0.60 = 6.3 mm = 0.54 x (11.6 mm)

$$1/\sqrt{2\pi} \int_{-0.54/2}^{0.54/2} \exp(-1/2^2 y^2) dy = 0.21$$

$$.21 \times \sqrt{6.5} = 0.54 \text{ throughput}$$

bandwidth = 3.7 eV

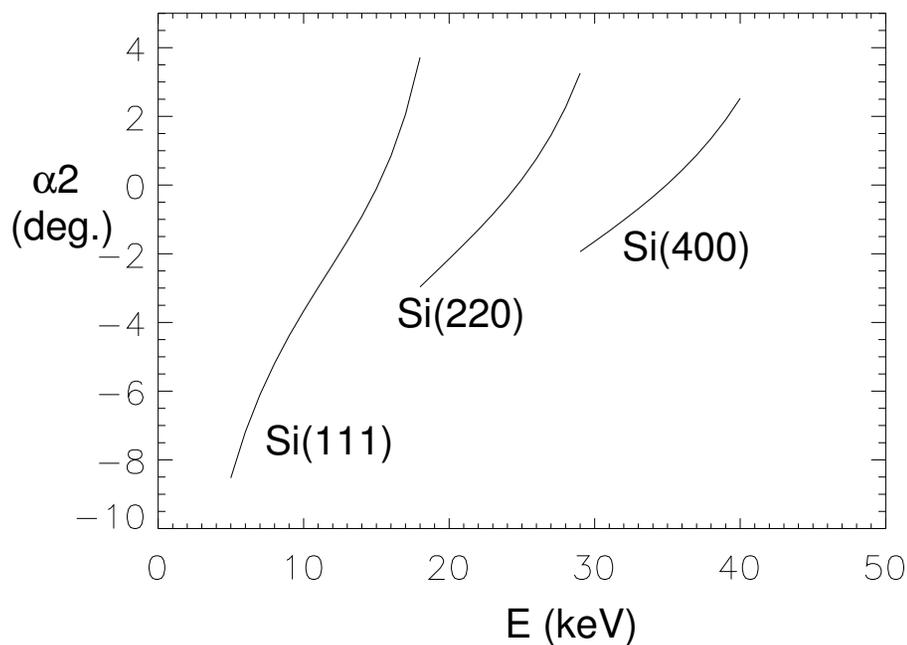
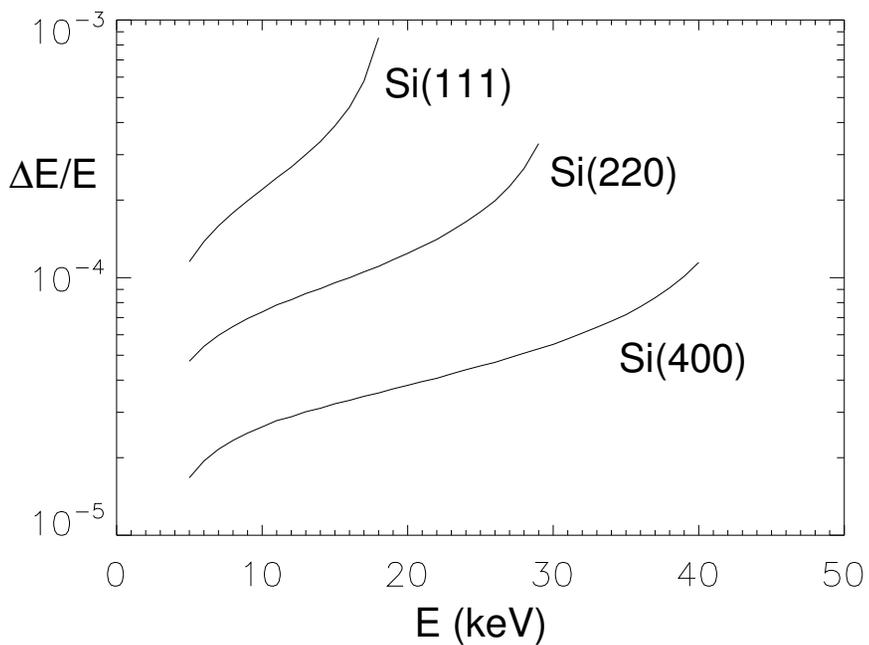
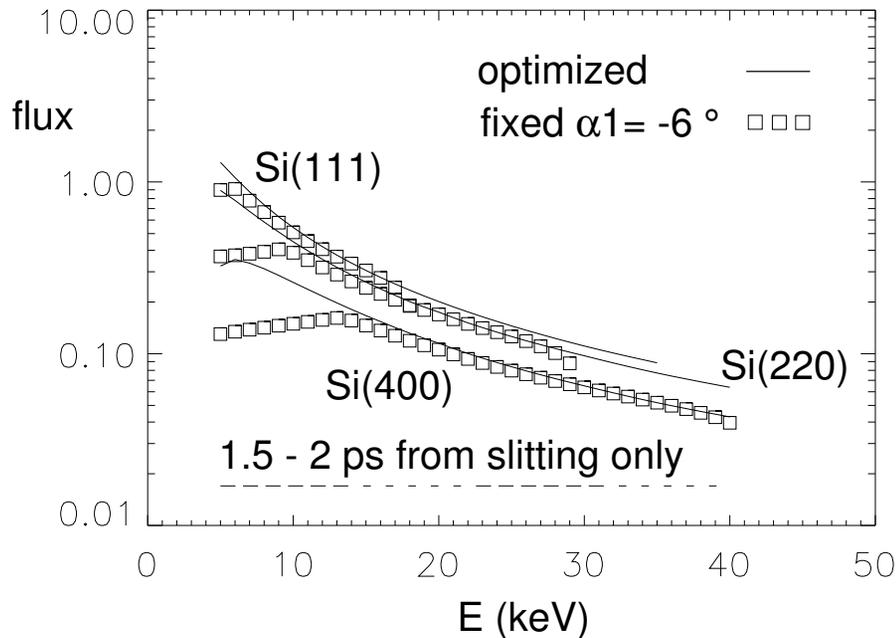


How Near-Optimized Can One Be with Fixed First-Crystal Asymmetry?

Fix 1st crystal asymmetry to

$$\alpha_1 = -6.0^\circ$$

Second crystal asymmetry α_2 varies to satisfy pulse compression condition

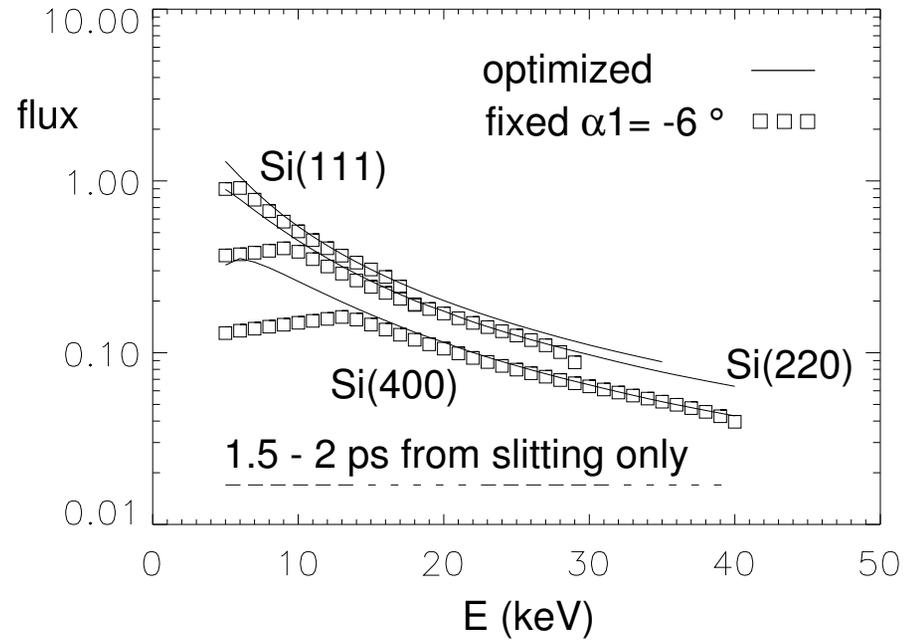


How Near-Optimized Can One Be with Fixed First-Crystal Asymmetry?

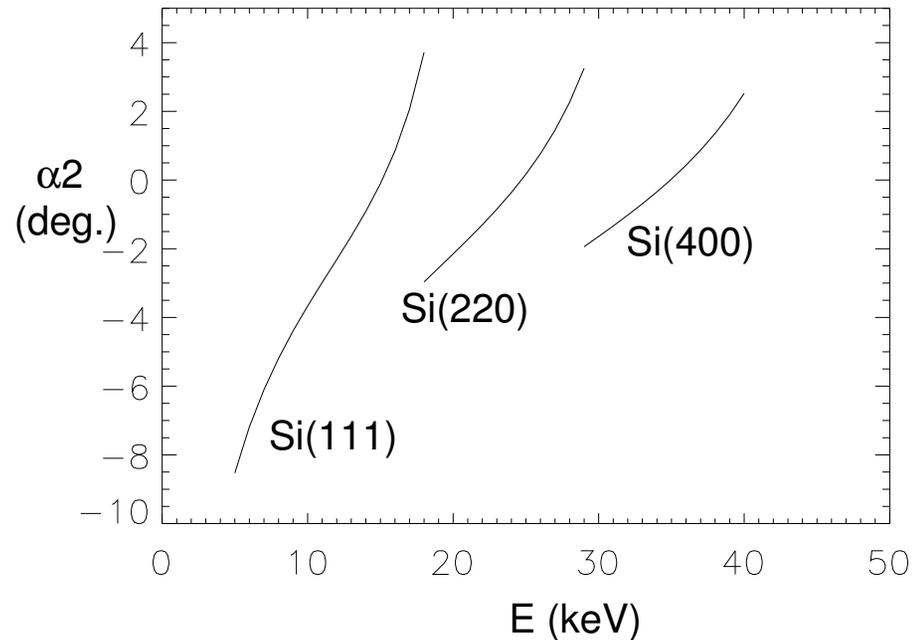
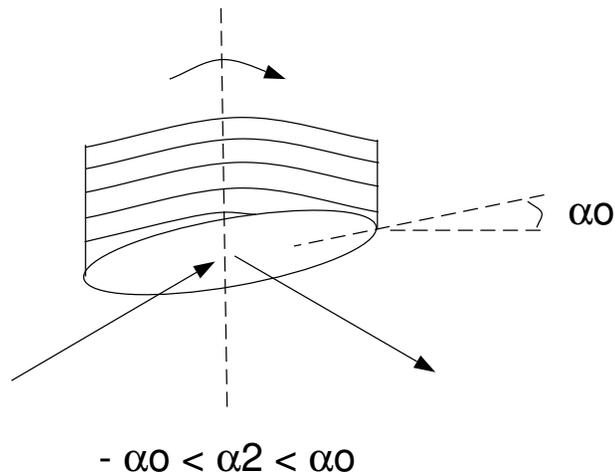
Fix 1st crystal asymmetry to

$$\alpha_1 = -6.0^\circ$$

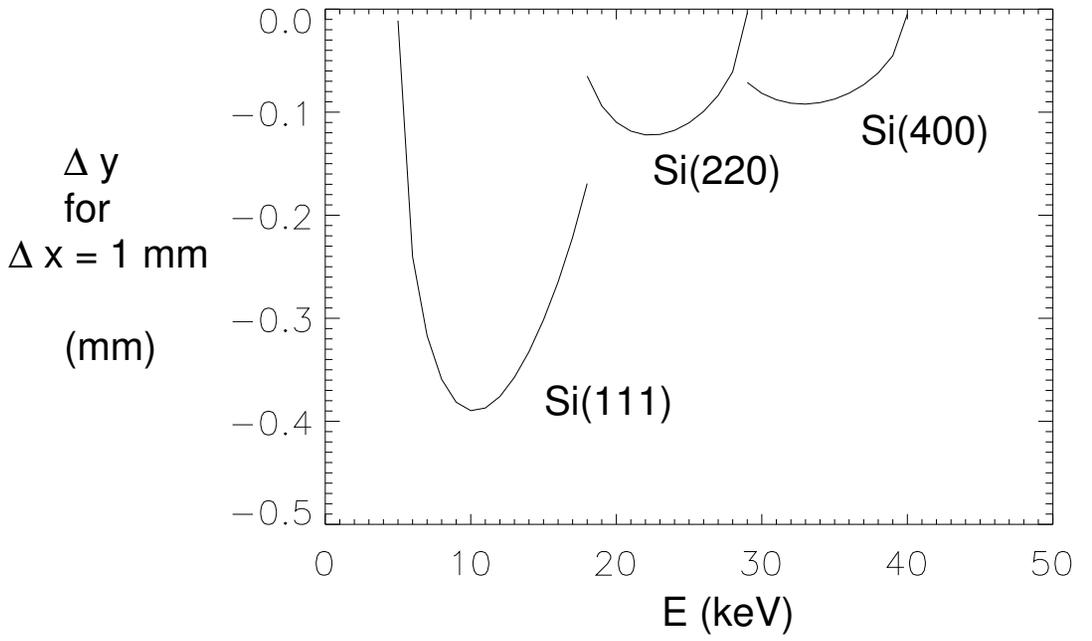
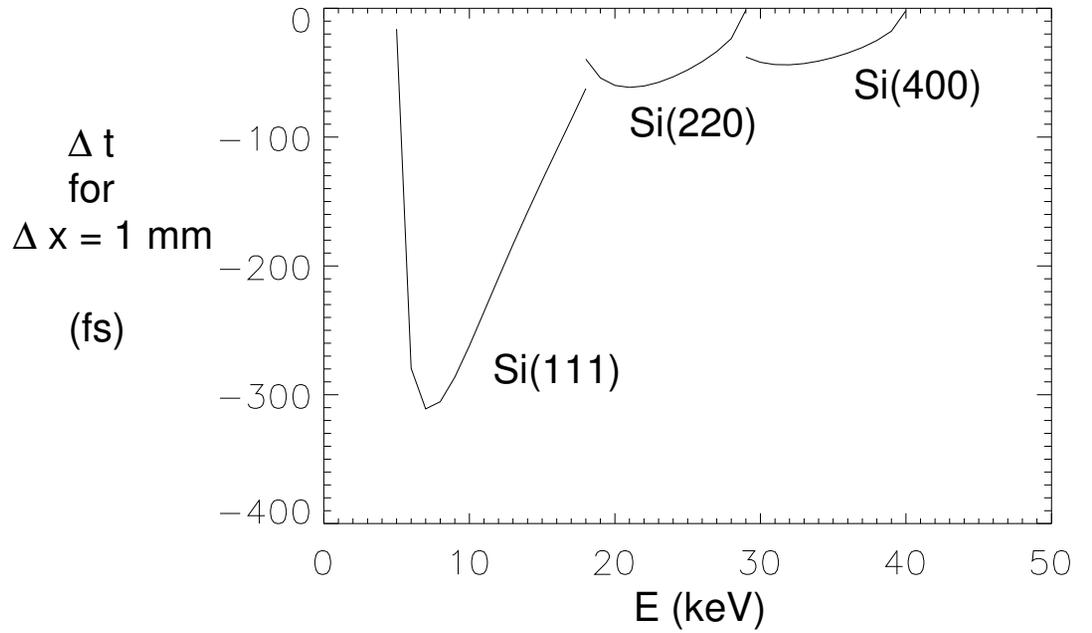
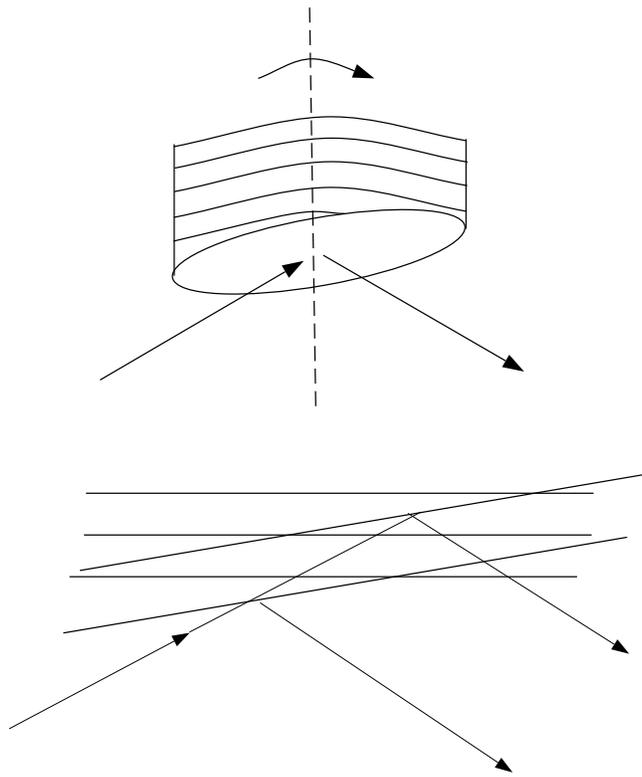
Second crystal asymmetry α_2 varies to satisfy pulse compression condition



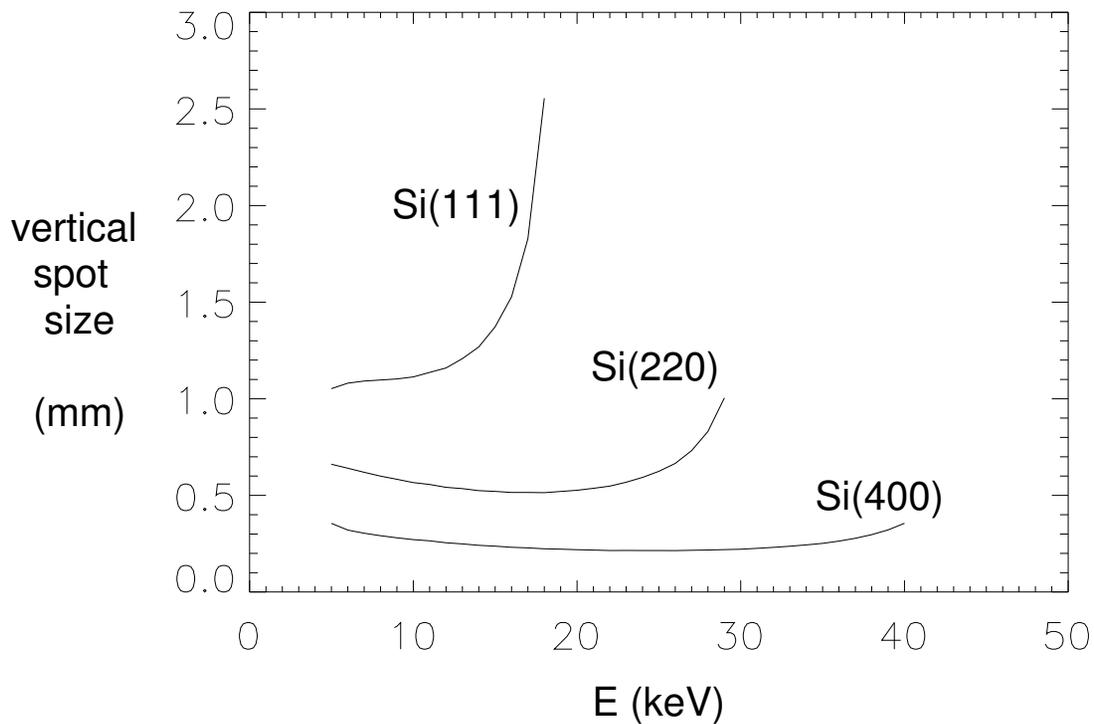
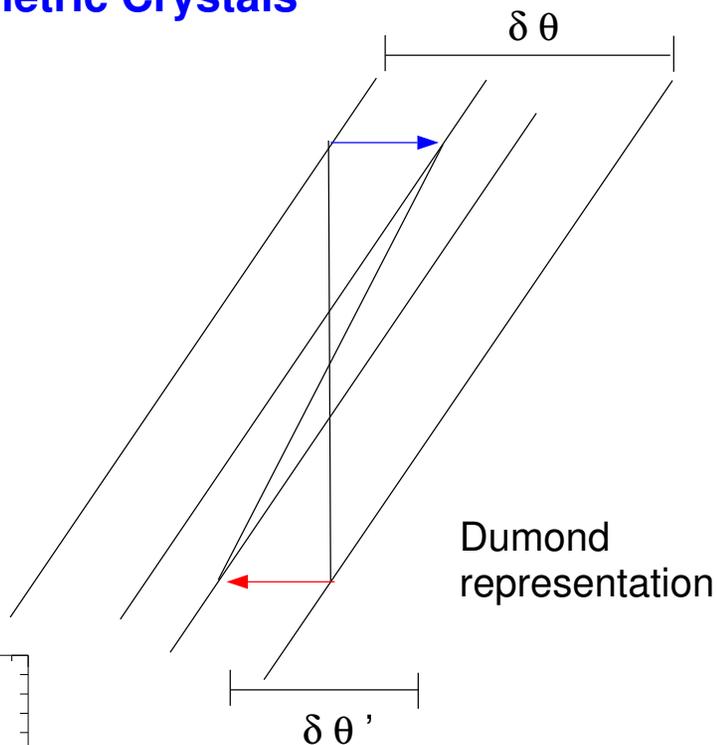
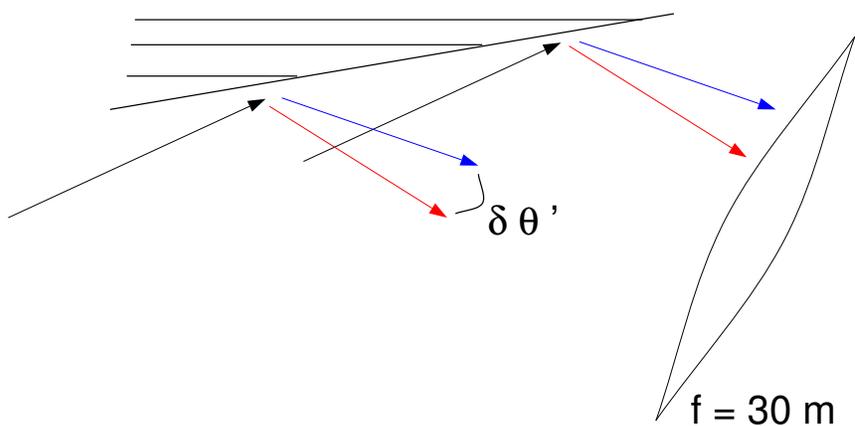
Continuously Tunable 2nd Crystal Asymmetry



Tunable Asymmetry Effects



Vertical Spot Size Due to Asymmetric Crystals



Single reflection
 $\delta \theta' = \delta \theta (1 + b)$

Double reflection
 $\delta \theta' = \delta \theta (1 - b_1 b_2)$

2nd Sagittal Mirror Length and Reflectivity / Coating

$$L = L_1 + L_2$$

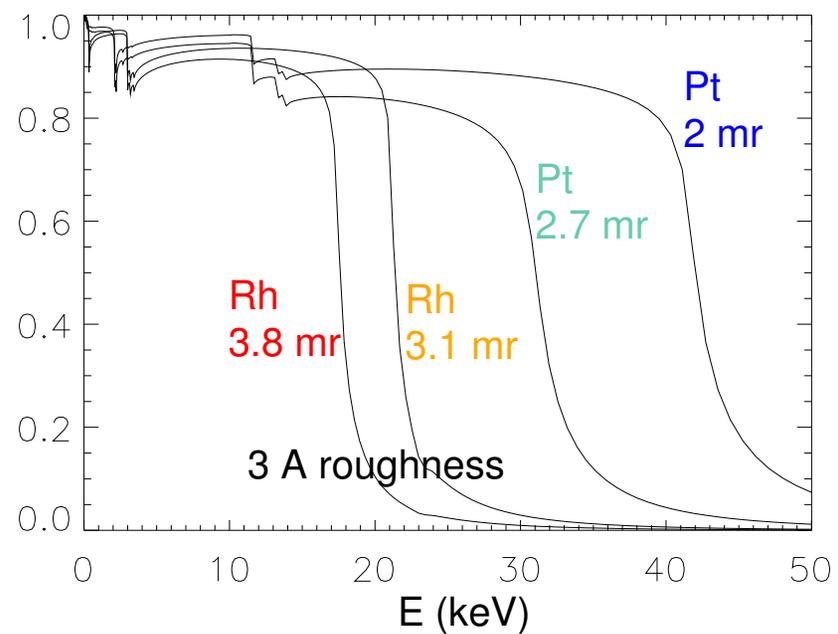
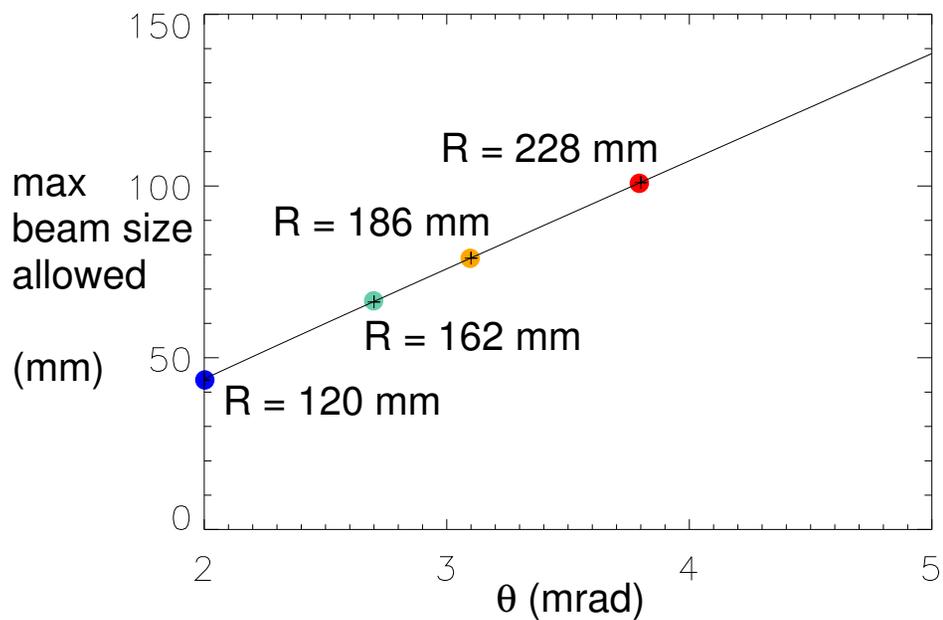
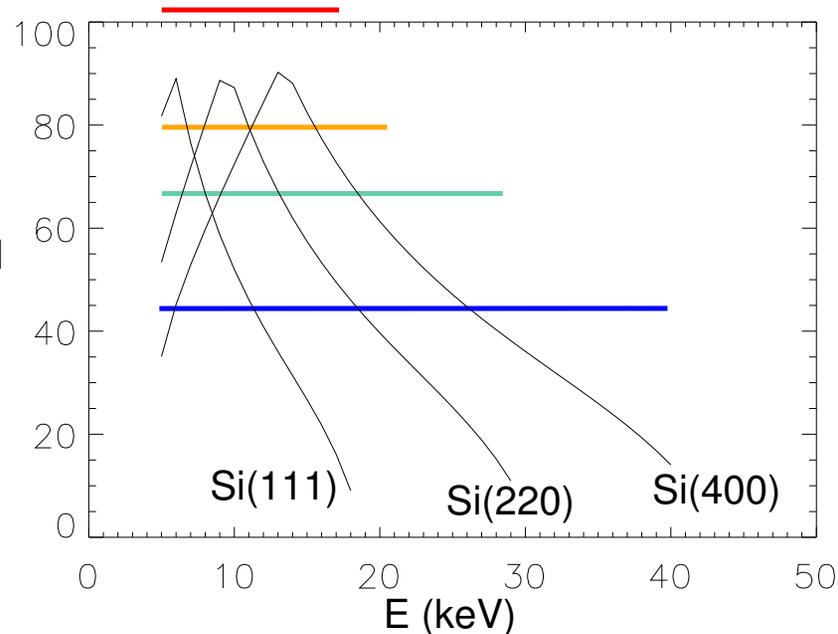
$$= \frac{h_m}{\theta} + \frac{h_s^2}{8 R \theta}$$

$$h_s < \sqrt{\left(L - \frac{h_m}{\theta}\right) 8 R \theta}$$

2 m
2 mm

vertical
beam size
before 2nd
mirror

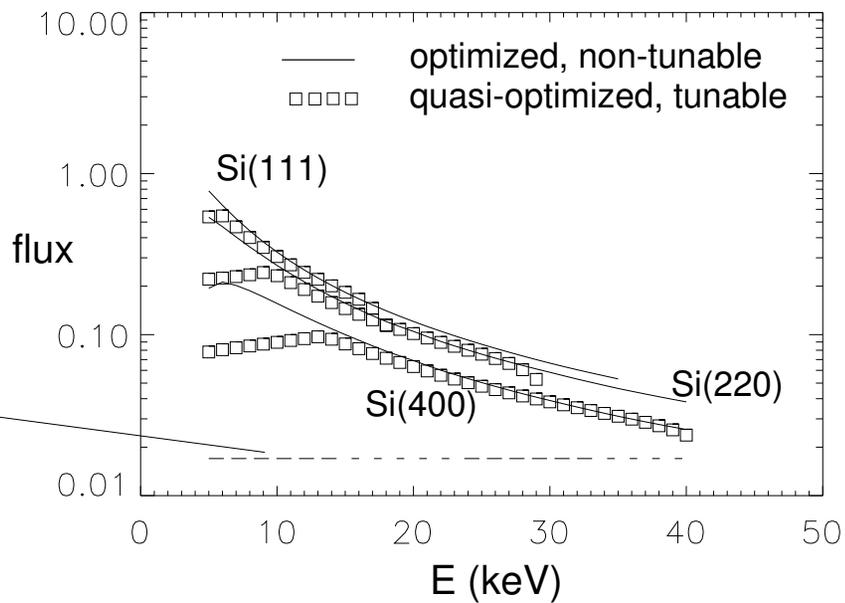
(mm)



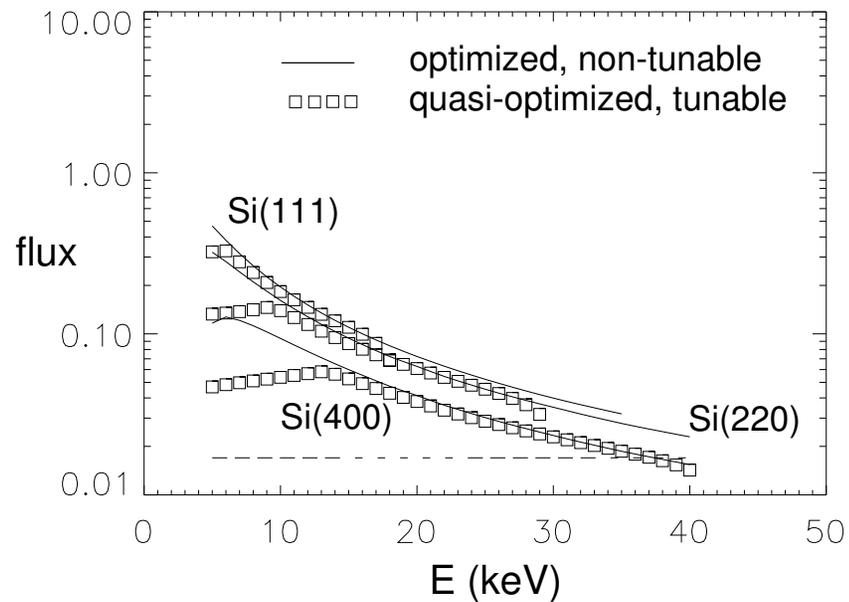
Throughput Including Mirror Reflectivities

2 m long second mirror

0.5 mm slit-only trans for 1.5 - 2 ps



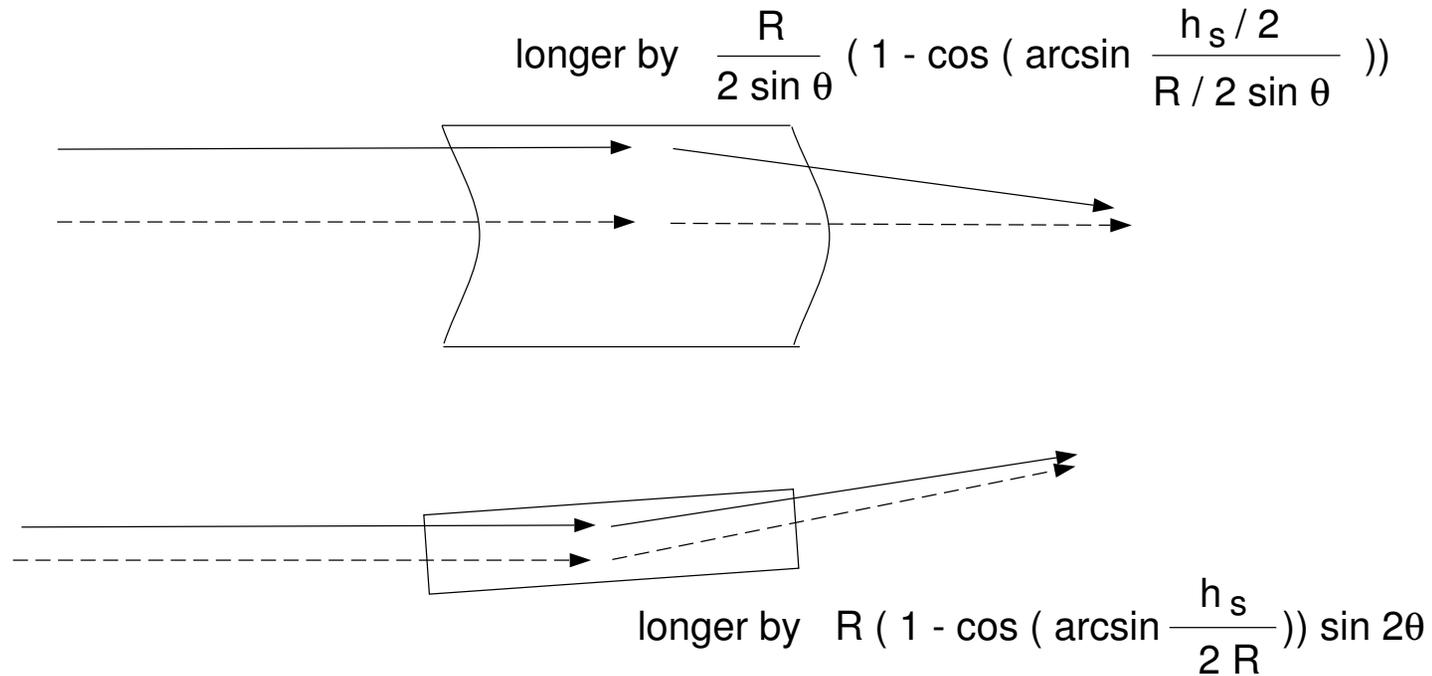
1 m long second mirror



Isochronicity of Sagittal Mirrors

Paths are isochronous, from Fermat's principle of stationary (least) time for aberration-free (parabolic) profile.

For cylindrical profile we have the following:

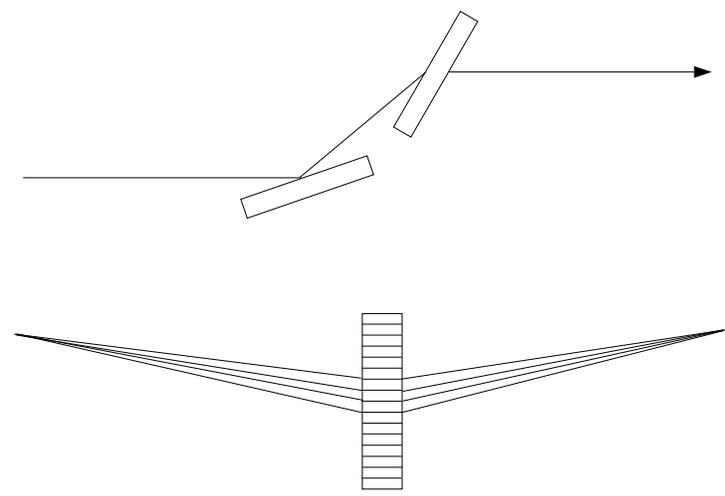
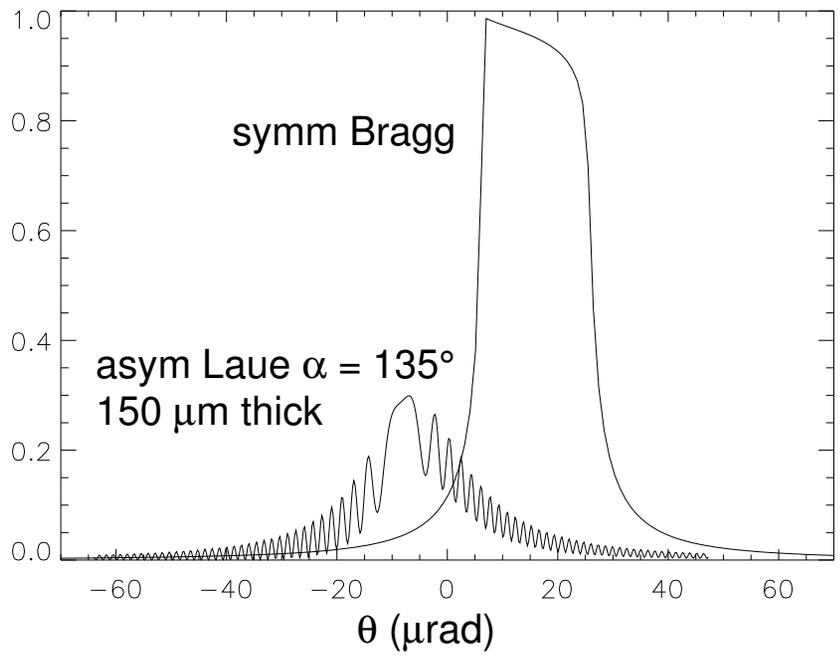
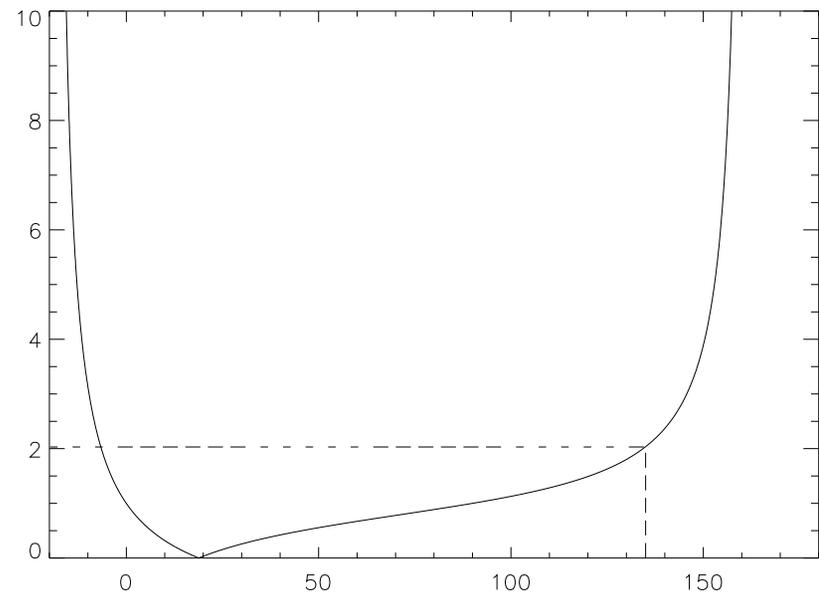
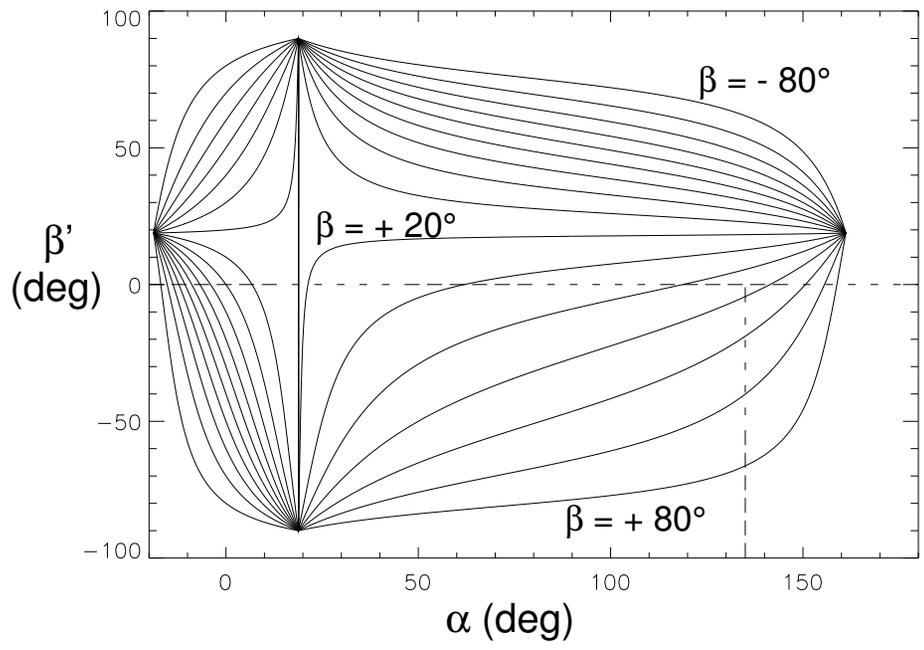


For $h_s = 100 \text{ mm}$, $\theta = 2 \text{ mrad}$, $R = 120 \text{ mm}$,

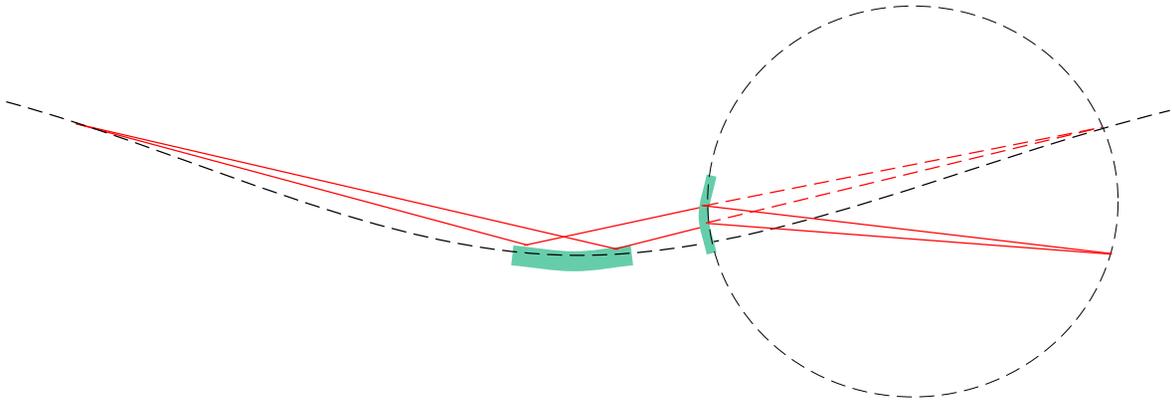
these lengths are $41.7 \text{ }\mu\text{m}$ and $43.7 \text{ }\mu\text{m}$,

difference of $2 \text{ }\mu\text{m}$ or 7 fs

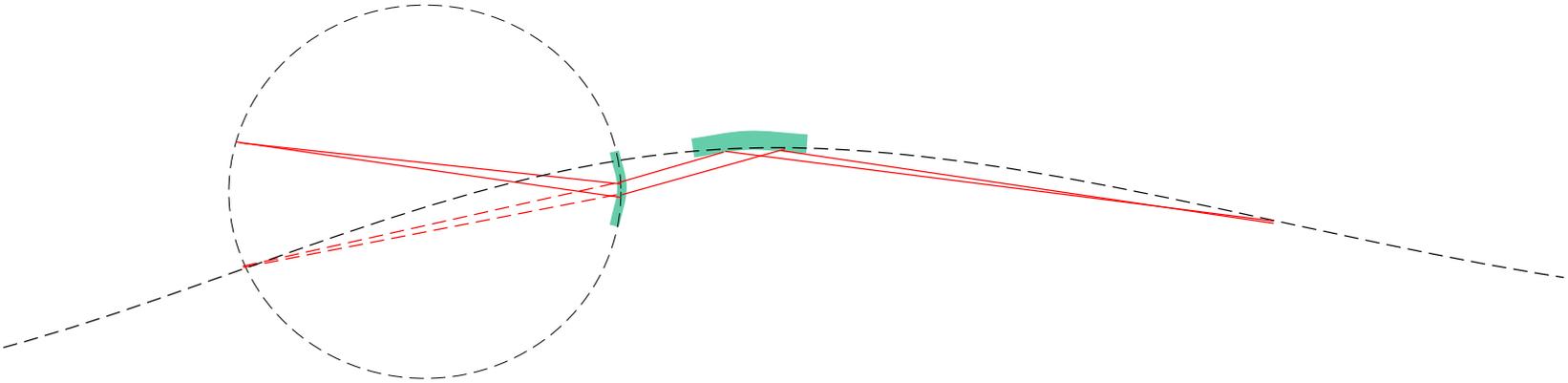
Tilt - Rotation, 10 keV, Si(220), Laue Geometry



Minimizing Energy Spread and Focusing Without Mirrors



Laue-Bragg geometry with bent crystals in nested Rowland conditions



Summary

- Implementing compression optics to get < 2 ps seems possible.
- Compared to slitting alone, compression optics throughput enhancement would be 15- to 2-fold over 5 - 30 keV.
- Flux at ~ 10 keV would be about an order of magnitude less than "what you are used to" (i.e., flux delivered by ordinary Si(111) monochromator in central radiation cone).
- A given optics system could be tuned/scanned in energy over roughly 10 keV wide ranges.
- Main "loose end" has to do with mirrors and focusing the transversely large, time-compressed beam to a reasonable (\sim mm) spot size. Simulations in progress.
- Microfocusing does not seem possible with compression, but can be done with just slitting alone.
- Remember: RF-deflection destroys the source vertical brilliance, resulting in large vertical divergence. One might have to do scattering experiments in the horizontal plane.